

Image AF/1763



Attorney Docket:  
33082 M 083

RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE REQUESTED  
GROUP 1763

Corres. and Mail  
**BOX AF**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**CONFIRMATION NO. 1607**

Applicants : Yutaka TAKAHASHI, et al.  
Serial No. : 09/864,374  
Filed : May 25, 2001  
Examiner : J. Lund  
Art Unit : 1763  
For : METHOD FOR FORMING OXYNITRIDE FILM OR THE LIKE  
AND SYSTEM FOR CARRYING OUT THE SAME

**AMENDMENT IN RESPONSE TO FINAL REJECTION**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 26, 2003, please amend the above-identified application as set forth below and consider the following remarks.